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# Microstresses in Thermally Stable Diamond Composites made by High Pressure Infiltration Technique

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**Abstract.** Microstresses in the diamond and SiC phases of the TSDCs (thermally stable diamond composites), produced by the high pressure infiltration technique, were measured using the neutron diffractometer, KOWARI, at the OPAL research reactor. Microstresses are developed as a result of the cooling and pressure reduction from the sintering high temperature and high pressure (HTHP) conditions. Their magnitude is determined by the thermo-mechanical properties of the SiC matrix and diamond grit, pressure and temperature conditions as well as the exact TSDC phase composition. The experimental results were interpreted in terms the "matrix-inclusion" composite model that was used to evaluate the composite structural integrity.

### Introduction

Diamonds composites are finding increasing use in mining, manufacturing and civil construction industries as cutting elements and drilling bits of various toolings. Although diamond is extremely brittle with low impact strength, the diamond composites have superior hardness and toughness better suited to these applications.

There are two diamond-based composite systems. So-called PCD (polycrystalline diamond composite) has a certain amount of metal binder phase, usually Co. The use of the metal binder restricts the operational temperature range for PCD to less than 800°C. The second system of diamond composites is TSDC, which extends the temperature range up to 1400°C [1]. TSDC is free of any metal binder, but a ceramic binder is used instead, usually SiC.

There are several methods of producing TSDC, but most commonly the diamond–SiC composites are produced by the liquid Si infiltration techniques involving reactive sintering. They share some common features to form SiC matrix/binder for the diamond particles since they are all based on reactive bonding operations, usually in HPHT conditions. During this operation, molten silicon infiltrates the diamond powder, reacts with the diamond powders that results in the formation of the diamond-SiC composite. On the other hand, the HPHT conditions can vary drastically. In some methods the sintering is carried out in the diamond stability region (~1500°C and ~5.5 GPa), while others operate in the graphite stable region (~1500°C and ~2.0 – 3.5 GPa) as in case of the process patented by Ringwood in 1980s [2]. There are some variations of the method that involve no pressure or very low pressure [3, 4]. In some cases pressure can be as high as 8-10 GPa and temperature as high as 1800-2000°C [5]. While the first two cases were analyzed for stress earlier [6], the later production route, high pressure silicon infiltration technique [5], is the focus of the current investigation.

While thermal stability is a very important property for a tool's performance, other properties such as impact resistance, thermal fatigue, fracture toughness and wear resistance are related to

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the stress state of the material. The residual stress originates from the manufacturing process, which is usually HPHT process, while the applied stress comes from severe mechanical/thermal loading these composites are subjected to during operation.

Since the current TSDC manufacturing processes involve such high temperatures and pressures, the residual stresses in such composite materials arise from (i) *thermal mismatch*, due to the difference in thermal expansion coefficient between the diamond and SiC matrix phase during the quenching to room temperate and (ii) *elastic mismatch*, due to the difference in bulk elastic modulus between diamond and SiC matrix phases during the pressure drop from high to ambient.

The infiltration process of liquid silicon into the diamond green body is a complex phenomenon. It involves percolation of liquid Si, dissolution of carbon into Si, reaction and formation of SiC. This process is particle-size sensitive and in certain conditions can lead to closure of pores in the diamond compact due to the sealing effect of the SiC formation. This effect is more pronounced for smaller particle sizes of the diamond green body and is also affected by the pressure conditions of the process when diamond particles experience fracturing with effective decrease in the particle size. All these processing variables, including even sample shape and size, can eventually lead to formation of specific microstructures (mostly micro-defect structures such as micro-porosity, micro-cracking and residual silicon) as well as residual microstresses.

# **Samples**

In the current study the focus is on the high pressure (8-10 GPa) high temperature (1800-2000°C) variation of the sintering technology [5]. Samples of two geometries were produced under the same high temperature (~1900°C) and high pressure (~9 GPa) conditions. The two sample geometries were (i) cylinders with diameter of 3 mm and height of 7 mm and (ii) 6 mm side triangular prisms with height of 4 mm (Fig. 1). For the cylindrical samples, finer diamond powder was used in conjunction with coarser grain size (30-40 µm) to provide better infiltration for the whole sample height. For the triangular prism samples finer diamond grit (20-30 µm) was used (Fig. 2). With two different diamond particle sizes and two shapes, the percolation conditions might differ, forming, as discussed above, somewhat different micro-mechanical systems characterized also by different stresses.

Two representative samples for each of the geometries were studied. Samples were characterized in the "as-manufactured" condition with no service history.

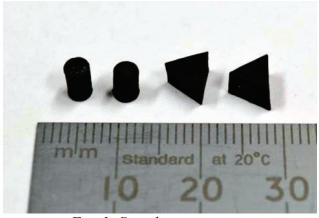


Fig. 1: Samples geometries.

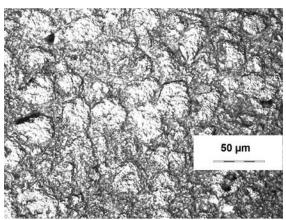


Fig. 2: Microstructure: optical microscopy image of the triangular sample surface.

## **Experimental: phase and stress analyses**

Two characterizations were conducted by means of neutron diffraction using diffractometers of the Australian research reactor OPAL.

Phase identification and quantitative phase analysis were done at the neutron high-resolution powder diffractometer, WOMBAT [7]. Neutron diffraction patterns were collected in the range of  $25^{\circ}$  to  $145^{\circ}$  using wavelength of 1.54 Å and WOMBAT's  $120^{\circ}$ -range large position sensitive detector. The patterns were analysed using Rietveld refinement technique (GSAS Rietveld refinement software with the EXPGUI interface [8]) to extract volume fractions of diamond and  $\beta$ -SiC (a cubic polymorph, formed at sintering temperatures below  $1700^{\circ}$ C). No other polymorphs of SiC or C and no residual Si were detected. The accuracy of phase fraction evaluation was better than 0.2 %.

Residual stress analysis was carried out using the neutron residual stress diffractometer, KOWARI [9]. In the residual stress experiment both phases of TSDC samples were measured: diamond (311) reflection and SiC (220) reflection at a wavelength of 1.52 Å. Bragg angles of these reflections were 90° and 58.4° respectively. Due to the overall size of the samples, a relatively small gauge volume with dimension 1.5×1.5×4 mm³ was used so that measurements could be made from the bulk of the smallest sample. During measurement the gauge volume was positioned in the center of each sample and the sample was rocked in the range of 20° to improve the grain statistics. The measurement time was 10-15 min for the diamond phase and 2-3 hours for the SiC phase.

A special test was made to check isotropy and uniformity of one fine grained (triangular prism) sample by measuring it in multiple directions and several different locations. Since no statistically significant variation in the lattice parameter was found, isotropy and uniformity was confirmed in this way and assumed in the following data analysis.

Determination of the unstressed d-spacing,  $d_0$ , is critical for correct microstrain and stress determination in composite materials; therefore it received special attention. The  $d_0$  values for

both phases,  $d_0^{SiC}$  and  $d_0^{Dia}$ , were assumed to be the same in all four samples considering the same treatment history. In principle, it is equations, sufficient use two corresponding to two samples, setting macrostress to zero,  $\sigma_i^{Macro} = f_i^{SiC} \sigma_i^{SiC} +$  $f_i^{Dia}\sigma_i^{Dia}=0$ , i=1,2 in order to resolve the system of two equations with two unknowns,  $d_0^{SiC}$  and  $d_0^{Dia}$ , and determine them in a unique way (assuming that  $f_1 \neq f_2$  to avoid degeneracy). In the above equation  $f_i^{\alpha}$  stands for the volume fraction of the  $\alpha$ -th phase and  $\sigma_i^{\alpha}$  is the total hydrostatic phase stress,  $\sigma_i^\alpha = \frac{1}{\frac{1}{2}S_2^\alpha(hkl) + 3S_1^\alpha(hkl)} \frac{d_i^\alpha - d_o^\alpha}{d_o^\alpha}$  ,  $\alpha = SiC$  ,  $Di\alpha$  . In the case of four samples, the system of such equations is overdetermined, therefore, d<sub>0</sub> values were defined in such a way that provided the condition of zero macrostress in all four samples simultaneously in the leastsquares minimization sense (minimizing the

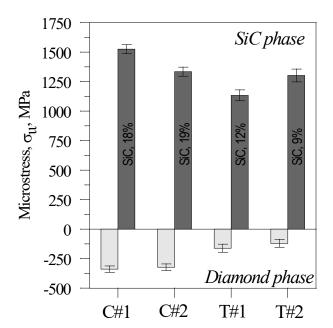


Fig. 3: Microstress of the SiC and diamond phases in the cylindrical (C) and triangular (T) samples.

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sum of all four squared macrostress residuals). Treated this way, the  $d_0$  for diamond and SiC were determined with accuracy of the same order of magnitude as the accuracy of the measurements,  $\sim 1 \times 10^{-5}$  for diamond and  $\sim 5 \times 10^{-5}$  for SiC.

Strain-to-stress calculations were carried out using appropriate hkl-dependent diffraction elastic constants calculated from the single crystal elastic constants of diamond and SiC [10]. Numerically,  $S_1(hkl)$  and  $\frac{1}{2}S_2(hkl)$  were -0.28 and 1.42  $TPa^{-1}$  for the diamond (311) reflection, while for the SiC (220) reflection they were -0.40 and 2.71  $TPa^{-1}$ .

## Results and discussion

The results of the neutron phase analysis and neutron stress analysis, based on experimentally determined phase composition are shown in Table 1 and visually illustrated in Fig. 3. With the accuracy of the phase analysis being better than 0.2 vol.%, the uncertainty in the volume fraction determination does not make any significant contribution to the overall uncertainty of the stress values. The finite strain measurement accuracy,  $\sim 15$  µstrain for diamond and 30-50 µstrain for SiC due to the neutron counting statistics is the major source of uncertainties of stress that are reported in Table 1. Additionally, some inaccuracy in  $d_0$ 's and/or the single crystal elastic constants can result in somewhat bigger errors.

The experimental check for isotropy not only suggests isotropy of the microstructure and its properties but was used as an assumption in the stress analysis so that one stress component, the hydrostatic microstress (or pressure), fully characterizes the stress state.

Sample ID	- C	Volume fraction	Stress in	Stress in SiC
	(diamond/SiC)	(diamond/SiC)	diamond [MPa]	[MPa]
Cylindrical samples				
C#1	0.83/0.17	0.82/0.18	$-339 \pm 27$	$1524 \pm 40$
C#2	0.82/0.18	0.81/0.19	$-323 \pm 28$	$1334 \pm 40$
Prism samples				
T#1	0.88/0.12	0.88/0.12	$-162 \pm 35$	$1133 \pm 46$
T#2	0.92/0.08	0.91/0.09	$-121 \pm 33$	$1302 \pm 54$

Table 1. Experimentally determined phase composition and phase microstresses.

### **Discussion**

The results of the stress analysis on the samples made by the high pressure infiltration technique are consistent with other TSDCs [6], with hydrostatic microstresses in diamond phase reaching several hundreds of MPa in compression equilibrated by tensile microstresses in SiC with magnitudes up to GPa and higher.

Interpretation of the results can be made using a micromechanical model of the generalized particulate composite employing spherical inclusion theory. The stress analysis by means of the Hashin-Shtrikman bounds [11], rather than relying on one specific model, assumes isotropic and particulate microstructure and provides a range of possibilities for matrix-inclusion interaction. In this approach the hydrostatic microstress can be evaluated as a function of a temperature or external pressure drop. The calculations based on a temperature change from the sintering to room temperature are given Fig. 4 in comparison with the experimental data. It is evident that all samples generally match the lower HS bound ("HS-", diamond matrix, SiC inclusions) very well. This suggests an inter-connectivity of the diamond particles so the diamond phase topology can be considered as a continuous framework with islands of SiC.

With such good agreement between experimental and calculated stresses, some implications can be deduced.

- (1) There is no pressure-drop-generated component in the overall stress state. If there was such a contribution present with pressure drop of  $\Delta P = 9$  GPa, then the overall expected stresses would be significantly lower, e.g some -40 MPa rather than the -340 MPa experimentally determined for the diamond phase in the cylindrical samples. Thus only thermally generated stresses appear through the production pathway when the external pressure is released immediately, while temperature is reduced to ambient temperature at a slower rate. The same conclusion was made through surface stress analysis by means of Raman spectroscopy of the TSDC samples produced by the same technique [12] - the magnitude of residual stress is primarily dependent on temperature conditions, not pressure change.
- (2) In the same way it can be deduced that there is no (or at least no significant) microcracking present in the samples, otherwise a significant stress relaxation with significantly lower absolute values of the microstresses would be detected. However, some speculations can be made regarding the triangular-shaped samples, where some stress

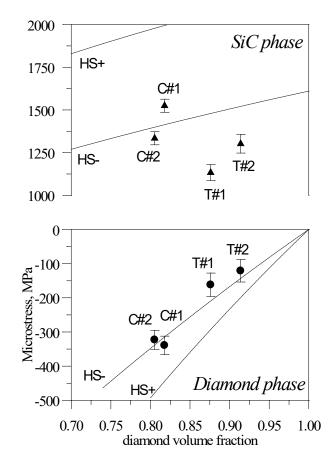


Fig. 4: Microstress in diamond and SiC phases for the TSDC samples: experimentally measured values (symbols) are plotted against predicted Hashin-Shtrikman bounds (lines).

relaxation can be observed, approximately 80 % from the expected values. The fact that the grain size of the diamond powder was smaller for these samples can be reflected in higher probability of the sealing effect with formation of isolated micro-pores. This can be responsible for the elastic weakening of the composite and can contribute to some stress relaxation.

# **Conclusions**

Two types of TSDC samples (diamond-SiC composite), produced by the silicon infiltration technique at HTHP conditions, were analyzed by means of neutron diffraction. Phase composition was obtained through the full diffraction pattern analysis to assist in the residual stress analysis. Neutron diffraction strain analysis was done in a single peak experiment and microstresses (phase incompatibility) were determined in the two phases, compressive in the diamond phase and tensile in the SiC phase.

The thermal nature of the experimentally determined microstress was deduced through the micromechanical analysis of the composite. The results suggest that almost all thermally generated microstresses are preserved in the samples. No significant sign of microcracking and stress relaxation was found, thus confirming the micromechanical integrity of the samples and suggesting good quality and performance of the TSDC samples.

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